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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Hitomi SAKURAI :
Serial No. 10/616,732 : Group Art Unit - 2812
Filed: July 10, 2003 : Examiner: Alexander G. Ghyka
For: METHOD FOR MANUFACTURING :
A SEMICONDUCTOR DEVICE : Docket No. S004-5072

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MS AF
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME
AND REQUIRED EXTENSION FEE**

S I R:

Applicant respectfully requests a one-month extension of time for replying to the Office Action dated April 6, 2005 and request that the period for taking further action be reset to expire on August 6, 2005. This is an extension request for replying to the April 6 Office Action within the first month pursuant to 37 CFR §1.136(a).

The reason for the present request is to provide additional time to study the April 6 Office Action and take appropriate action in response thereto.

08/11/2005 NWOLDGE1 00000037 10616732

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120.00 OP

MAILING CERTIFICATE ON PAGE 2

A check in the amount \$120.00 is enclosed herewith to cover the required fee. Should the check prove insufficient for any reason, authorization is hereby given to charge any such insufficiency to our Deposit Account No. 01-0268.

Respectfully submitted,

ADAMS & WILKS
Attorneys for Applicant

By: 

Bruce L. Adams
Reg. No. 25,386

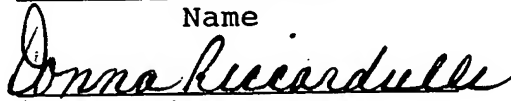
17 Battery Place
Suite 1231
New York, NY 10004
(212) 809-3700

MAILING CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: MS FEE AMENDMENT, COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

DONNA RICCARDULLI

Name


Signature

AUGUST 5, 2005

Date